

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

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Atty. Docket No. 04329.2566		Serial No. 09/842403 Not Yet Assigned					
Applicant Shinichi ITO et al.							
Filing Date April 26, 2001		Group 2823					
U.S. PATENT DOCUMENTS							
Examiner Initial*	Document Number	Date	Name	Class	Sub Class	Filing Date If Appropriate	
<i>Mle</i>	6,066,575	5/23/2000	Reardon et al.	438	782		
<i>Mle</i>	6,162,745	12/19/2000	Ito et al.	438	795		
FOREIGN PATENT DOCUMENTS							
Examiner Initial*	Document Number	Date	Country	Class	Sub Class	Translation Yes or No	
<i>no translation</i>	9-320950	12/12/97	Japan			No	
	2000-150352	5/30/2000	Japan			No	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
	ITO et al., "LIQUID FILM FORMING METHOD", US Patent Application Serial No. 09/669,725, filed September 26, 2000.						
	ITO et al., "APPARATUS AND METHOD OF FORMING LIQUID FILM". US Patent Application Serial No. 09/335,508, filed December 20, 2000.						
	IKEGAMI, et al., "DEPOSITION APPARATUS", US Patent Application Serial No. 09/817,196, filed March 27, 2001.						
Examiner <i>Michelle Asturado</i>		Date Considered 11/25/02					
<p>*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>							
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INFORMATION DISCLOSURE
CITATION

Atty. Docket No.

Serial No.

4329.2566

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U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

<u>*Examiner Initial</u>	<u>Document Number</u>	<u>Date</u>	<u>Country</u>	<u>Class</u>	<u>Sub-Class</u>	<u>Translation</u>
						<u>Yes</u> <u>No</u>

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

RE Copy of U.S. Patent Application Serial No. 09/735,553, filed December 14, 2000 to Ema et al.

Examiner

Date Considered

11/25/02

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INFORMATION DISCLOSURE CITATION

Atty. Docket No.	04329.2566	Serial No.	09/842,403
Applicant	Shinichi ITO et al.		
Filing Date	April 26, 2001	Group:	-2842- 2823

U.S. PATENT DOCUMENTS

Examiner Initial*	Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate
<i>MIC</i>						

FOREIGN PATENT DOCUMENTS

	Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No
<i>MIC</i>	JP 02-220428 A	09/1990	Japan	—	—	English Abstract
<i>MIC</i>	JP 06-151295 A	05/1994	Japan	—	—	English Abstract
<i>MIC</i>	JP 07-321001 A	12/1995	Japan	—	—	English Abstract
<i>MIC</i>	JP 2000-077326 A	03/2000	Japan	—	—	English Abstract

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner	<i>Michelle Estrada</i>	Date Considered	<i>11/25/02</i>
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